

Received: 28 May 2015 Accepted: 13 January 2016 Published: 15 February 2016

OPEN Exfoliation and Raman **Spectroscopic Fingerprint of Few-**Layer NiPS₃ Van der Waals Crystals

Cheng-Tai Kuo^{1,2,*}, Michael Neumann^{1,2,*}, Karuppannan Balamurugan^{1,2}, Hyun Ju Park^{1,2}, Soonmin Kang^{1,2}, Hung Wei Shiu³, Jin Hyoun Kang⁴, Byung Hee Hong⁴, Moonsup Han⁵, Tae Won Noh^{1,2} & Je-Geun Park^{1,2}

The range of mechanically cleavable Van der Waals crystals covers materials with diverse physical and chemical properties. However, very few of these materials exhibit magnetism or magnetic order, and thus the provision of cleavable magnetic compounds would supply invaluable building blocks for the design of heterostructures assembled from Van der Waals crystals. Here we report the first successful isolation of monolayer and few-layer samples of the compound nickel phosphorus trisulfide (NiPS₃) by mechanical exfoliation. This material belongs to the class of transition metal phosphorus trisulfides (MPS₃), several of which exhibit antiferromagnetic order at low temperature, and which have not been reported in the form of ultrathin sheets so far. We establish layer numbers by optical bright field microscopy and atomic force microscopy, and perform a detailed Raman spectroscopic characterization of bilayer and thicker NiPS₃ flakes. Raman spectral features are strong functions of excitation wavelength and sample thickness, highlighting the important role of interlayer coupling. Furthermore, our observations provide a spectral fingerprint for distinct layer numbers, allowing us to establish a sensitive and convenient means for layer number determination.

Mechanical exfoliation of Van der Waals-stacked graphite provided a means to isolate monolayer and few-layer graphene sheets, and demonstrated that the electrical, optical, mechanical and chemical properties of two-dimensional (2D) materials vary strongly with the number of atomic layers^{1,2}. For example, whereas graphite is a robust semimetal, monolayer graphene is a zero-bandgap Dirac metal, the electrical properties of which are strongly modulated by the influence of external factors such as adsorbates³ or the presence of a substrate^{4,5}. The same exfoliation method has since been applied to a large number of layered Van der Waals materials, including insulating hexagonal boron nitride⁵, the high-temperature superconductor Bi₂Sr₂CaCu₂O_{8+δ} (Bi-2212)^{6,7}, and the family of stacked transition metal dichalcogenide materials, MX₂, with tetravalent M^{IV} such as Nb, Mo, Ta, W, Re, and chalcogen X = S, Se, Te^{6,8}. Amongst these, molybdenum disulfide (MoS₂) has received particular attention due to its novel electronic properties, with a transition from an indirect bandgap found in bulk and multilayer MoS_2 to a direct bandgap in monolayer $MoS_2^{9,10}$. Proceeding beyond their already fascinating properties, the isolated monolayers and multilayers of different stacked compounds can be reassembled to yield Van der Waals heterostructures and superlattices that may exhibit even more exotic behavior11, and this has fueled an ongoing search for new compounds with tailored physical and chemical properties that can be exfoliated as ultrathin sheets. In particular, for the design of spintronic devices¹², Van der Waals materials that exhibit magnetic order would be highly desirable building blocks. However, with the exception of the antiferromagnetic parent compound of the high-T_c superconductor Bi-2212 mentioned above, the isolation of exfoliated monolayer or few-layer samples from Van der Waals materials with magnetic order at low temperature has not been reported. Thus, there is limited availability of materials both for the incorporation of spin order into complex Van der Waals heterostructures, and for fundamental studies of the impact of dimensionality onto magnetism in exfoliated samples with controlled numbers of layers.

¹Center for Correlated Electron Systems, Institute for Basic Science (IBS), Seoul 151-742, Republic of Korea. ²Department of Physics and Astronomy, Seoul National University (SNU), Seoul 151-742, Republic of Korea. ³National Synchrotron Radiation Research Center (NSRRC), Hsinchu 30076, Taiwan. ⁴Department of Chemistry, Seoul National University (SNU), Seoul 151-742, Republic of Korea. 5Department of Physics, University of Seoul, Seoul 130-743, Republic of Korea. *These authors contributed equally to this work. Correspondence and requests for materials should be addressed to T.W.N. (email: twnoh@snu.ac.kr) or J.G.P. (email: jgpark10@snu.ac.kr)

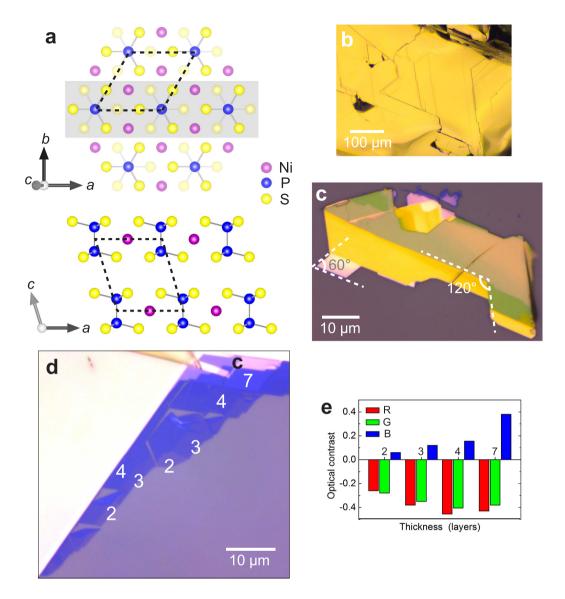


Figure 1. Atomic structure and optical characterization of exfoliated NiPS₃. (a) Schematic crystal structure. View perpendicular to layers, only top layer shown (upper schematic). The atoms contained in the section shaded grey are shown in view parallel to layers (lower schematic). Unit cell (dashed outlines), covalent bonds within $(P_2S_6)^{4-}$ anions (grey lines). (b) Brightfield microscope image of cleaved bulk NiPS₃ samples. (c) Image of NiPS₃ flake exfoliated onto oxidized silicon substrate, comprising mainly thick sheets (>10 layers). 60° and 120° angles indicated. (d) Image of thin exfoliated NiPS₃ sheets, 2–7 layers indicated. (e) Optical intensity contrast of ultrathin NiPS₃ sheets (2–7 layers), evaluated for red, green, and blue color channels separately, with reference to the substrate. (Photos in panels (c) and (d) were acquired at different illumination conditions to maximize visibility of relevant features).

The transition metal phosphorus trisulfide compounds, MPS₃, form a separate family of stacked materials for which the interaction between layers occurs via Van der Waals forces^{13,14}. All members comprise layers of covalently bonded (P_2S_6)⁴⁻ bipyramids and a honeycomb arrangement of divalent transition metal ions (Fig. 1a). The M^{II} site can be occupied by any 3d elements from V to Zn and by the 4d element Cd, and stoichiometric compounds have been synthesized with M = Mn, Fe, Co, Ni, Zn, Cd¹⁵. All of these compounds are stacked in an ABC fashion and have monoclinic crystal structure (space group C_{2h}^3)^{13,16}; see Supplementary Table S1 for lattice parameters and key physical properties. Importantly, MPS₃ exhibits magnetism for M = Mn, Fe, Co, Ni^{15,17,18}, with a Curie-Weiss susceptibility at high temperature, and antiferromagnetic order at low temperature. The magnetic behavior is governed by competing direct M-M exchange and indirect M-S-M superexchange interactions within layers, as well as interlayer exchange interactions, and at low temperature, different antiferromagnetic ordering patterns are observed^{15,17,18}. There are few theoretical predictions for the magnetic behavior of MPS₃ materials in the ultrathin limit. Monolayer MnPS₃ sheets have been predicted to exhibit strong coupling of the valley degree of freedom to the antiferromagnetic spin order on the Mn honeycomb lattice, allowing for strong valley polarization¹⁹. Nanosheets of MnPS₃ have been calculated to form antiferromagnetic semiconductors that

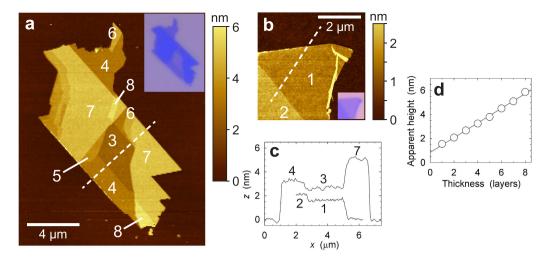


Figure 2. AFM characterization of exfoliated NiPS₃. (a,b) Tapping-mode AFM topography image of ultrathin NiPS₃ sheets, (a) 3–8 layers indicated, (b) 1 and 2 layers indicated. Insets: corresponding optical photographs. (c) Height profiles along the lines shown in (a,b). (d) Apparent layer heights evaluated from the AFM scans in (a,b), from 1 to 8 layers. Step heights between consecutive layers are ~0.6 nm, base height offset with respect to bare Si/SiO₂ substrate is ~0.8 nm.

become ferromagnetic semimetals upon carrier doping, with opposite spin polarization for electron and hole doping 20 , and similar phenomena are thought to exist in other MPS $_3$ compounds.

Another property of the MPS₃ compounds that make the study of their exfoliated 2D variants attractive is the strong dependence of their optical properties on the M-site element, with absorption edge energies ranging between 1.5–3.5 eV²¹. Furthermore, due to their ability to accommodate extrinsic species in the Van der Waals gap, accompanied by dramatic modifications of their magnetic, optical and electrical properties, the MPS₃ materials provide a suitable platform for intercalation-chemical studies^{15,21}. In particular, the ability to reversibly intercalate lithium into the Van der Waals gap prompted great interest in the use of MPS₃ as cathode materials for lithium batteries, with NiPS₃ appearing to be the most promising candidate for potential application²².

Exfoliation of bulk CdPS₃ and MnPS₃ by an ion exchange method in aqueous solution resulted in a suspension of Cd_{0.8}PS₃ and Mn_{0.8}PS₃ monolayer flakes with lateral size \approx 50 nm^{23,24}. However, the experimental realization of stoichiometric ultrathin MPS₃ sheets with lateral sizes in the micrometer range that allow for the study of intrinsic 2D material properties has not been reported so far.

Results/Discussion

In this article, we present the first experimental demonstration of MPS $_3$ monolayer and multilayer samples isolated by mechanical exfoliation, for the case of NiPS $_3$. Bulk samples of NiPS $_3$ (Fig. 1b) are grown by a vapour transport method. Using the well-known Scotch tape method, we exfoliate NiPS $_3$ flakes onto silicon substrates capped by 90 nm silicon oxide (SiO $_2$). In the resulting NiPS $_3$ sheets, we observe that sheet edges and boundaries between regions of different layer numbers frequently run in parallel, or are arranged at angles close to 60° and 120° (Fig. 1c). As in the case of exfoliated graphite, this observation can be attributed to preferential crack-propagation along the high-symmetry crystal axes during exfoliation.

Figure 1d shows an optical brightfield microscope image of a region containing thin NiPS₃ sheets as well as thicker flakes. Thick flakes appear as opaque yellow areas, whereas atomically thin flakes exhibit discrete levels of optical contrast with respect to the substrate, allowing for unambiguous discrimination between regions of different layer number. For a semi-quantitative estimate, the optical image recorded on a CCD camera can be decomposed into its red, green, and blue intensity channels. For each color channel, the optical contrast between an n-layer (nL) flake and the substrate is calculated from the color intensities as $C_{nL} = (I_{nL} - I_{subs})/I_{subs}^{25}$. Fig. 1e demonstrates that discrete contrast levels are obtained for different sample thicknesses in each color channel.

Layer numbers of thin NiPS₃ sheets are assigned *via* a combination of optical contrast and height determination by atomic force microscopy (AFM). Figure 2a shows an AFM scan of a sheet comprising areas that are 3–8 layers thick, with lateral dimension 2–8 μ m, and Fig. 2b shows a NiPS₃ sheet of monolayer and bilayer thickness, along with height profiles across the flakes and the SiO₂ substrate (Fig. 2c). The measured layer heights shown in Fig. 2d illustrate that the spacing between NiPS₃ flakes of different thickness is quantized in units of ~0.6 nm, consistent with the known bulk NiPS₃ layer spacing $c \sin \beta = 0.63$ nm. However, the apparent height of monolayer NiPS₃ with respect to the substrate, ~1.5 nm, is much greater than the interlayer spacing. We confirm that our assignment of monolayer and bilayer thicknesses is correct by performing an AFM scan on a sample containing bilayer and 5-layer sheets that overlap partially, allowing for an unambiguous calibration of our layer thickness scale (Supplementary Fig. S3). The phenomenon of an apparent base height offset is routinely observed in AFM measurements on exfoliated materials, such as graphene^{1,26}, MoS₂²⁷⁻²⁹, and other dichalcogenides^{30,31}. It is commonly attributed to the presence of trapped adsorbates³² and to chemical contrast, *i.e.*, a difference in the

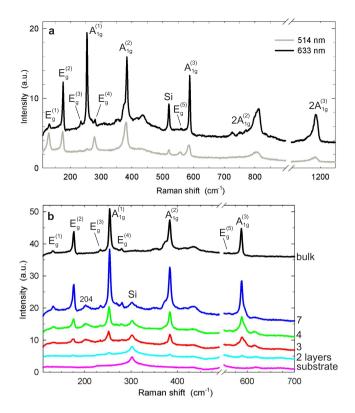


Figure 3. Raman spectra of exfoliated NiPS₃. (a) Spectra of a thick sheet ($d \approx 107\,\mathrm{nm}$), acquired at excitation wavelengths $\lambda_{exc} = 514$ and 633 nm. These spectra are indistinguishable from those reported for bulk NiPS₃. 5 in-plane E_g and 3 out-of-plane A_{1g} phonon modes are indicated. The Raman peak of silicon visible at $520\,\mathrm{cm}^{-1}$ stems from the substrate. (b) Spectra of thin NiPS₃ sheets (2–7 layers), acquired at $\lambda_{exc} = 633\,\mathrm{nm}$, together with the spectrum of a thick sheet shown in panel (a), and the substrate spectrum. All spectra were acquired in a single pass, under identical experimental conditions, on the sample shown in Fig. 1d. Spectra have not been scaled; data are offset vertically for clarity. The spectral region dominated by the first-order Raman peak of the silicon substrate around $520\,\mathrm{cm}^{-1}$ has been omitted. The spectral feature at ~300 cm⁻¹ is a second-order Raman peak of silicon⁵⁶.

interaction strength of the silicon AFM tip with the exfoliated flakes and the SiO_2 substrate, respectively. Phase lag data that we acquire in AFM measurements (Supplementary Fig. S2) unambiguously show that significant chemical contrast between $NiPS_3$ flakes and the SiO_2 substrate is present, demonstrating that this mechanism contributes to the apparent height offset.

Raman spectroscopy is a powerful and popular characterization tool for bulk and exfoliated Van der Waals materials such as graphite/graphene and transition metal dichalcogenides $^{26-31,33-38}$. The Raman spectra of bulk MPS3 and of $(P_2S_6)^{4-}$ molecular anions in solution have been studied extensively both experimentally and theoretically $^{39-45}$. Bulk NiPS3 is monoclinic (point group C_{2h}^3), with a unit cell comprising two formula units $(Ni_2P_2S_6)$ in each layer. If the interlayer coupling is treated as a small correction, phonon modes can instead be labelled in terms of the D_{3d} point group of the hexagonal NiPS3 monolayer, and we follow this terminology to simplify comparison with the theoretical calculations of Bernasconi 14. For spectra acquired in a backscattering geometry, first-order processes encompass phonons at the Brioullin zone center only. The irreducible representation of the zone center modes, $\Gamma = 3A_{1g} + 2A_{2g} + A_{1u} + 4A_{2u} + 5E_g + 5E_u$, predicts 8 Raman-active phonon modes $(3A_{1g} + 5E_g)$, and all of these have been experimentally observed for bulk NiPS3 44 .

In Fig. 3a, we show the Raman spectra of a thick NiPS₃ flake (thickness \approx 107 nm) that can be regarded as bulk material, measured at excitation wavelengths 514 and 633 nm. The spectra are consistent with previously reported Raman spectra of bulk NiPS₃, and we assign the 8 expected Raman-active phonon modes according to that earlier work⁴⁴. Since we probe the Raman response for two different excitation wavelengths, we can observe that the intensities of spectral features are a strong function of excitation energy. For excitation at 633 nm, all first-order modes are present, and the in-plane $E_g^{(2)}$ mode and all three out-of-plane A_{1g} phonon modes dominate the spectrum. In contrast, in the spectrum collected at $\lambda_{\rm exc}=514$ nm, the $A_{1g}^{(1)}$ mode is very weak, and the $E_g^{(3)}$ mode is not observed, whereas the $E_g^{(1)}$ and $E_g^{(4)}$ modes are enhanced; previous work⁴⁴ reported an almost identical spectrum acquired at $\lambda_{\rm exc}=488$ nm. This dependence on incident wavelength is presumably due to selective resonance enhancement controlled by electron-phonon coupling; however, to our knowledge no theoretical studies of this phenomenon that would allow for a more detailed discussion have been performed for MPS₃ materials to date. Besides the spectral features assigned to first-order phonon processes, the Raman spectra contain several additional modes. For $\lambda_{\rm exc}=633$ nm, the spectral region between 400–450 cm⁻¹ contains broad peaks that were

also observed in previous work^{44,45}, and the spectral region between 700–850 cm⁻¹ contains numerous peaks that have been interpreted as second-order processes⁴⁵. Furthermore, we observe prominent features close to $1200 \, \mathrm{cm^{-1}}$ that have not been previously reported and that we assign to the second overtone of the $A_{1g}^{(3)}$ phonon mode

Figure 3b shows the Raman spectra of thin NiPS₃ sheets of 2, 3, 4, and 7 layers thickness, acquired for excitation $\lambda_{\rm exc}=633\,\rm nm$, along with the spectra of thick sheets and the substrate. All spectra were measured in a single pass on the NiPS₃ sample shown in Fig. 1d, *i.e.*, sequentially and under identical experimental conditions. It is seen that as the layer number decreases, the spectral features undergo a significant evolution in several ways. Most visibly, while most Raman peaks are more intense in the 7-layer sheet than they are for bulk NiPS₃, their intensity exhibits a marked progressive reduction in tetralayer, trilayer, and bilayer sheets. Intriguingly, the Raman features associated with the three A_{1g} phonon modes also exhibit qualitative changes that make the spectra of bilayer through 7-layer NiPS₃ sheets distinct and provide each of them with a unique fingerprint. Additionally, a peak that is not observed for bulk samples appears at \approx 204 cm⁻¹ for sheets of 3–7 layers thickness. For $\lambda_{\rm exc}=514\,\rm nm$, the evolution of Raman spectra with sample thickness shown in Supplementary Fig. S6 is qualitatively similar but differs in a few important aspects. In particular, at this excitation wavelength, the spectrum of bilayer NiPS₃ is almost indistinguishable from the SiO₂ substrate, in contrast to the case of $\lambda_{\rm exc}=633\,\rm nm$.

We note that photoluminescence is absent from all spectra acquired for $\lambda_{\rm exc}=514$ and 633 nm, for bilayer through 7-layer sheets and thick samples alike, up to the wavenumber limit of our spectra, 3000 cm $^{-1}$. This observation rules out a transition of the indirect bandgap $\Delta=1.6\,{\rm eV}$ to a direct bandgap in thin NiPS $_3$ sheets. Furthermore, we can place a lower bound on the direct bandgap of thin NiPS $_3$, $\Delta_{\rm dir}>2.4\,{\rm eV}$ (corresponding to $\lambda_{\rm exc}=514\,{\rm nm}$). We remark that it remains unknown whether a transition to a direct bandgap takes place in monolayer NiPS $_3$, similar to the case of MoS $_2^{9,10}$. This is due to the technical challenge of obtaining monolayer sheets of sufficiently large size; the monolayer sheet depicted in Fig. 2b of $\sim 3\,\mu{\rm m}$ lateral size is suitably large, but it suffered degradation due to prolonged exposure to ambient atmosphere before Raman and photoluminescence spectra could be collected (see Supplementary Information). Other identified monolayer sheets had small lateral dimensions $\sim 200\,{\rm nm}$.

In Fig. 4, we present a detailed analysis of the Raman spectral regions that contain the three out-of-plane A_{1g} phonon modes, for $\lambda_{\rm exc}=633\,\rm nm$. The phonon modes can be visualized by indicating the associated vibrational amplitudes and directions of all atoms contained in the monolayer $\rm M_2P_2S_6$ unit cell, based on the calculations of Bernasconi⁴⁴ (Fig. 4a,e,i). For all three A_{1g} modes, the Raman line shapes can be adequately described by either a single Lorentzian curve or a superposition of two Lorentzian curves for thin sheets comprising 2-7 layers and for thick sheets (Fig. 4b,f,j), and we determine the positions and integrated intensities of these peaks by least-squares fits to spectral data. We discuss the trends observed in the extracted quantities in the following. Between 2 and 7 layers, the integrated intensity I scales approximately linearly with sheet thickness for all three A_{1g} phonon modes, rising by a factor $20\sim25$ over this range (Fig. 4d,h,l). Presumably, this increase is partly due to a combination of a volume effect and constructive interference enhancement. For bulk NiPS₃, the intensity is significantly reduced with respect to 7 layers. Similar reductions of peak intensities with increasing sample thickness, from thin sheets to bulk, have been observed in the Raman response of other exfoliated materials such as graphene and MoS₂. This effect is attributed to the suppression of constructive interference enhancement due to the absorption of incident and scattered light in the bulk sample^{27,46}.

The intensity evolution for thin NiPS $_3$ sheets contains an additional, more subtle anomaly. Intensity I and layer number N are not proportional to each other, and in particular, linear extrapolation to N=0 would lead to large negative intensity offsets, suggesting that the Raman response of NiPS $_3$ bilayers is anomalously weak. The evolution of the normalized intensity I/N with layer number (blue plots in Fig. 4d,h,l) highlights both the deviation from the expected proportionality and the very weak bilayer Raman emission. An explanation of this phenomenon in terms of damping caused by destructive interference is ruled out by the observation that all three A_{1g} modes, despite their different emission wavelengths, exhibit similarly low responses. We speculate that instead this anomalously weak Raman response points to unusual intrinsic properties of bilayer NiPS $_3$, or to a strong influence of coupling to the substrate. The low intensity of Raman spectra in NiPS $_3$ bilayers is in stark contrast to materials such as graphene and MoS $_2$, for which the Raman response intensity of mono- and bilayers is comparable to, or even exceeds that of bulk samples 27,46 .

We proceed to discussing our observations for the individual A_{1g} phonon modes. We focus on spectra collected at $\lambda_{\rm exc}=633\,{\rm nm}$, while making reference to spectral data acquired at 514 nm excitation wavelength when these exhibit qualitative differences. The Raman peaks of the $A_{1g}^{(1)}$ mode can be described well by a single Lorentzian line shape at $k\approx254\,{\rm cm^{-1}}$. The central frequency of this peak (Fig. 4c) undergoes a significant blue-shift as a function of sheet thickness, by $\Delta k\approx2.5\,{\rm cm^{-1}}$ between trilayer and bulk samples. For the $A_{1g}^{(1)}$ mode, atomic vibrations primarily involve rigid vertical motion of the sulfur planes, while the phosphorus and metal atoms remain at rest (Fig. 4a), *i.e.*, this mode strongly modulates the Van der Waals gap. Accordingly, the blue-shift $\Delta k/k\approx1\%$ is most easily interpreted in terms of an $A_{1g}^{(1)}$ mode stiffening due to an increasing effective restoring force induced by the interaction with the added layers. Analogous observations have been reported for the out-of-plane phonon modes of exfoliated dichalcogenide materials, with similar magnitudes $\Delta k/k\approx1\%^{27-31,36-38}$. We remark that as in the case of bulk NiPS₃, for $\lambda_{\rm exc}=514\,{\rm nm}$ the $A_{1g}^{(1)}$ Raman mode is almost completely suppressed in sheets of 2-7 layers thickness (Supplementary Fig. S7).

The phonon modes $A_{1g}^{(2)}$ and $A_{1g}^{(3)}$ exhibit similarly dramatic changes with increasing sheet thickness, but their behavior is qualitatively different. Unlike the $A_{1g}^{(1)}$ mode, the vertical components of their sulfur plane vibrations are weak (Fig. 4e,i), and no mode stiffening is observed with increasing layer number. Figure 4f shows Raman

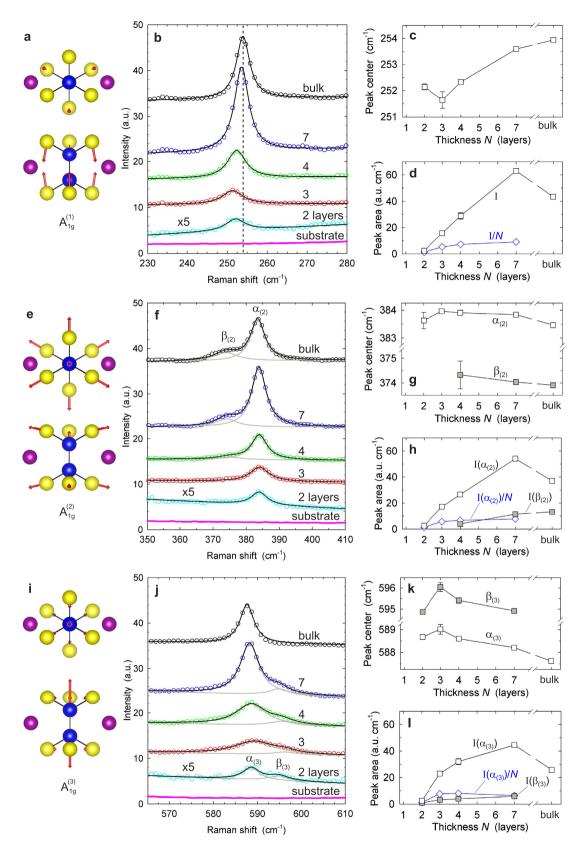


Figure 4. Out-of-plane A_{1g} phonon modes, and analysis of corresponding Raman spectral peaks of exfoliated NiPS₃, for excitation at 633 nm. (a) Schematic representation (top view, side view) of vibrational amplitudes of Ni₂P₂S₆ unit cell atoms in $A_{1g}^{(1)}$ phonon mode⁴⁴. (b) Detailed view of Raman data in corresponding spectral range, for thin sheets (2–7 layers), thick sheet, and silicon substrate. Spectra are overlayed with Lorentzian line shape fits. Data of bilayer sample have been magnified by factor 5. Spectra are offset vertically for clarity. (c) Central frequencies determined by Lorentzian peak fits in (b). Error bars correspond to spread of

experimental data. (d) Integrated line shape intensities I (=peak area) determined by Lorentzian peak fits in (b). (e-h) Analogous information for $A_{1g}^{(2)}$ phonon mode. Raman spectra of 4-layer, 7-layer and thick NiPS $_3$ sheets are composed of two distinct Lorentzian lines: individual Lorentzian fit curves (grey lines) and sum of fit curves (black lines). (i-l) Analogous information for $A_{1g}^{(3)}$ phonon mode. Raman spectra of thin sheets (2–7 layers) contain two superimposed Lorentzian lines.

spectra of the $A_{1g}^{(2)}$ mode. For this mode, the response of bilayer and trilayer sheets is described well by a single Lorentzian peak at $\alpha_{(2)}=384~{\rm cm^{-1}}$. In contrast, the spectra of 4- and 7-layer sheets and bulk NiPS₃ flakes contain an additional component at $\beta_{(2)}=374~{\rm cm^{-1}}$. For excitation at 514 nm, Raman spectra of the $A_{1g}^{(2)}$ mode (Supplementary Fig. S7) evolve in a similar manner. The mechanism governing the appearance of the additional feature at $\beta_{(2)}$ is unclear so far. We note that for MoS₂, the appearance of a low-energy component in the A_{1g} peak that increases in intensity with layer number has also been observed⁴⁷. Generally, the breaking of translational crystal symmetry for thin sheets implies that they belong to symmetry classes that are different from the bulk material. This can lead to observable qualitative changes of the phonon modes in ultrathin sheets, as reported for the case of exfoliated dichalcogenide materials⁴⁸. For NiPS₃, the strong evolution of the feature at $\beta_{(2)}$, and its absence in bilayer and trilayer sheets, could be attributed to such differences in point group. Alternatively, the observed behavior could be assigned to the influence of the coupling to the SiO₂ substrate, which is expected to affect very thin sheets most strongly.

Spectra of the $A_{1g}^{(3)}$ phonon mode shown in Fig. 4j vary in a similarly dramatic manner as a function of thickness, yet they show a converse trend. For thin sheets of 2-7 layers, two Lorentzian line shapes are present, at $\alpha_{(3)}=588\,\mathrm{cm}^{-1}$ and $\beta_{(3)}=595\,\mathrm{cm}^{-1}$, whereas the spectrum of bulk NiPS $_3$ contains only the dominant peak at $\alpha_{(3)}$. We will argue below that the mode at $\beta_{(3)}$ does contribute to second order Raman features, both for thin sheets and for thick samples. This implies that the phonon mode at $\beta_{(3)}$ remains present in bulk NiPS $_3$ but is Raman-inactive. The phenomena observed for excitation at 514 nm (Supplementary Fig. S7) are similar: for 4-and 7-layer sheets, two peaks can be resolved at $\alpha_{(3)}$ and $\beta_{(3)}$, whereas in thick sheets the peak at $\beta_{(3)}$ is absent. In addition, we observe a lower-energy peak at 583 cm $^{-1}$ that is unique to bulk NiPS $_3$. As before, the fact that thin sheets and bulk NiPS $_3$ belong to different point groups might explain the invisibility of the mode at $\beta_{(3)}$ for bulk samples.

Among the five doubly degenerate in-plane phonon modes of NiPS₃, the $E_g^{(2)}$ mode is most prominent. Supplementary Figure S8 shows the evolution of the corresponding spectral region with sample thickness, for $\lambda_{\rm exc}=514$ and 633 nm. In addition to the $E_g^{(2)}$ main peak centered at $176\,{\rm cm}^{-1}$, a low-energy shoulder located at $167\,{\rm cm}^{-1}$ can be resolved for 3–7 layers and thick sheets. Significantly, an additional peak that has not been observed in bulk NiPS₃ appears at ~204 cm⁻¹ in thin sheets, and for $\lambda_{\rm exc}=633\,{\rm nm}$ this peak can be clearly resolved for trilayer, tetralayer, and 7-layer sheets. The same consideration of translational symmetry breaking can be invoked to explain the appearance of this new spectral feature.

At this point, we briefly review the dependence of Raman-active phonon modes on the excitation wavelength. It was pointed out above that the $A_{1g}^{(1)}$ phonon mode is suppressed for excitation at 514 nm but dominates Raman spectra for $\lambda_{\rm exc}=633$ nm. The origin for this strong enhancement is unclear so far. In contrast, the remaining dominant modes $A_{1g}^{(2)}$, $A_{1g}^{(3)}$, and $E_{g}^{(2)}$ have a strong Raman response at both excitation wavelengths, and their intensity ratios I (514 nm)/I (633 nm) (Supplementary Fig. S9) exhibit a significant evolution with sheet thickness. With decreasing layer number, the intensity ratios exhibit a progressive enhancement over the bulk NiPS₃ values for all three phonon modes. This observation could be attributed to a thickness-dependence of the electronic structure of few-layer sheets. For bilayer NiPS₃, the observed trend is reversed abruptly as all intensity ratios vanish. This reversal reflects the absence of a Raman response in bilayers at $\lambda_{\rm exc}=514$ nm discussed previously, and it highlights that bilayer NiPS₃ behaves qualitatively differently from sheets of greater thickness, including trilayers.

The Raman spectra of bulk NiPS₃ and thin sheets contain several very distinctive features that arise from two-phonon processes. In the wavenumber region >700 cm⁻¹, the Raman response is dominated by two clusters of spectral peaks. Figure 5a shows the region between 700-900 cm⁻¹, in which second-order processes have been observed but not analyzed in previous work⁴⁵. This region contains numerous spectral features, and we perform a least-squares fit analysis to attain a more detailed understanding. For bulk and 7-layer NiPS3, spectra are adequately described by a superposition of 8 Lorentzian line shapes, centered at wavenumbers provided in the figure labels. We argue that at least a subset of these spectral peaks correspond to second-order overtones of the $A_{1g}^{(2)}$ phonon mode: doubling the wavenumber shifts of the $A_{lg}^{(2)}$ modes' two component peaks leads to $2\alpha_{(2)}=768\,\mathrm{cm^{-1}}$ and $2\beta_{(2)}=748\,\mathrm{cm^{-1}}$, in close agreement with the observed Lorentzian peaks centered at 769 and 751 cm⁻¹, respectively. The physical mechanisms that lead to the appearance of the two dominant peaks at 803 and 813 cm⁻¹ as well as the remaining smaller components are not clear at present. The intensities of all peaks decrease strongly as the layer number is reduced. For tetralayer NiPS₃, four Lorentzian lines can be resolved in total; whereas the two dominant peaks remain clearly visible, the peaks at $2\alpha_{(2)}$ and $2\beta_{(2)}$ merge into a single featoral; whereas the two dominant peaks remain clearly visible, the peaks at $2\alpha_{(2)}$ and $2\beta_{(2)}$ merge into a single featoral; ture that cannot be resolved further. For trilayer and bilayer sheets, a singlé peak described adequately by a Lorentzian line shape is visible at the position of the two previously dominant features. The evolution of the same spectral region for excitation at 514 nm is shown in Supplementary Fig. S10. For 7-layer sheets, spectra measured at the two excitation wavelengths are qualitatively similar, and four of the previously observed Lorentzian components are clearly resolved for $\lambda_{\rm exc}=514\,{\rm nm}.$ In striking contrast, spectra of bulk NiPS $_3$ differ greatly between the two excitation wavelengths; at 514 nm, only two strongly attenuated broad peaks can be resolved.

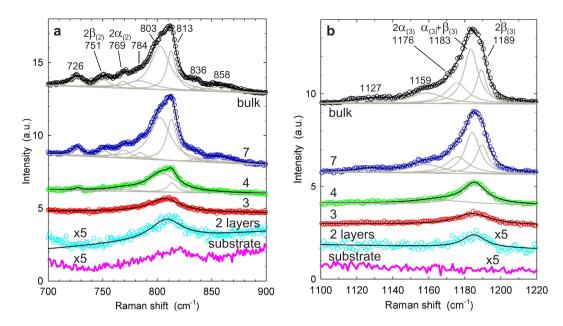


Figure 5. Raman spectral features of second order processes, at λ_{exc} = 633 nm. (a) Detailed view of spectral range containing $2A_{1g}^{(2)}$ second-order processes. Spectra are described by superposition of up to 8 Lorentzian peak shapes: individual Lorentzian fit curves (grey lines) and sum of fit curves (black lines). Labels state wavelength shifts (in cm⁻¹) of individual peak centers. Data of bilayer sample and substrate have been magnified by factor 5. Spectra are offset vertically for clarity. (b) Spectral range containing $2A_{1g}^{(3)}$ second-order processes. Spectra are described by up to 5 Lorentzian line shapes. See the text for details.

Figure 5b shows the Raman response in the range \geq 1100 cm⁻¹, which contains a cluster of spectral peaks that has not been previously reported. Using an analogous least-squares fit procedure, we decompose the spectrum for bulk and 7-layer NiPS₃ into 5 Lorentzian lines. The three lines that are comprised in the dominant spectral feature can be attributed to second order overtones and combination modes of the $A_{1g}^{(3)}$ phonon mode: the three possible combinations of that mode's two components lead to $2\alpha_{(3)}=1176~{\rm cm}^{-1}$, $\alpha_{(3)}+\beta_{(3)}=1183~{\rm cm}^{-1}$, and $2\beta_{(3)}=1190~{\rm cm}^{-1}$, in close agreement with the observed peak positions at 1176, 1183, and 1189 cm⁻¹, respectively. There is no clear interpretation so far for the two additional peaks that are visible at lower energies. As before, all peak intensities decline rapidly with decreasing layer number. For tetralayer NiPS₃, two Lorentzian lines are sufficient to describe the spectra, and for trilayer and bilayer sheets a single peak is resolved. Analogous to earlier comments, measurements of the $2A_{1g}^{(3)}$ spectral region at $\lambda_{\rm exc}=514~{\rm nm}$ (Supplementary Fig. S10) resolve far fewer component peaks for bulk NiPS₃ and 7-layer sheets, and in the bulk case the collected spectrum is greatly attenuated.

Our survey of the first- and second-order spectral features contained in the Raman response of NiPS₃ sheets of 2, 3, 4, and 7 layer thickness, and of bulk NiPS₃, demonstrates that for each sample thickness a qualitatively unique Raman spectrum is obtained. In particular, bilayer NiPS₃ is identified by its characteristic dependence on incident wavelength: at $\lambda_{\rm exc}=633\,{\rm nm}$ all dominant phonon modes are present, whereas at 514 nm the Raman spectrum is indistinguishable from the spectrum of the substrate. Trilayer and tetralayer NiPS₃ are discriminated by the spectral positions of their $A_{1g}^{(1)}$ peaks, as well as by the qualitative differences between their $A_{1g}^{(3)}$ peak shapes (Fig. 4j and Supplementary Fig. S6). For thicker sheets, our observations suggest that the position of the $A_{1g}^{(1)}$ peak and the linear rise of the $A_{1g}^{(1)}$ and $A_{1g}^{(2)}$ mode intensities allow for layer number identification at least up to 7-layer NiPS₃. The existence of such spectral fingerprints can be utilized for a rapid and convenient determination of layer numbers in thin NiPS₃ flakes.

Conclusion

We have reported the first successful fabrication and characterization of ultrathin transition metal phosphorus trisulfide (MPS₃) sheets, by micromechanical exfoliation of NiPS₃, down to isolated monolayers. Further, we have demonstrated that the Raman spectra of thin NiPS₃ sheets are drastically different from the bulk material, and vary strongly between sheets of different layer numbers. The key significance of our results is that bulk MPS₃ compounds exhibit magnetism, and antiferromagnetic ordering strongly influenced by interlayer coupling is known to take place for M = Mn, Fe, Co, Ni at moderately low temperature. Magnetic order in bulk MPS₃ crystals has previously been studied by means of Raman spectroscopy, which detects the modification of phonon modes due to a magnetic superstructure below the Néel temperature^{41–43}, and this technique can be extended to exfoliated MPS₃ sheets using a micro-Raman spectrometer for sufficiently large flakes (greater than the laser spot size ~1 μ m). If MPS₃ sheets can be deposited onto a conducting substrate or covered with a conducting coating to prevent electrostatic charging, X-ray photoemission electron microscopy is a suitable tool to characterize antiferromagnetic order directly with high spatial resolution ~50 nm^{49,50}. Thus, our work lays the foundation for the

study of magnetic order and competing magnetic exchange interactions in thin MPS₃ crystals of well-defined layer numbers, for an exploration of the impact of translational symmetry breaking and proximity of a substrate onto magnetic ordering phenomena, as well as for the application of spin-ordered monolayer and multilayer sheets as building blocks in Van der Waals heterostructures.

Methods

NiPS₃ crystals are grown by vapour transport method using 5% excess sulfur⁵¹. X-ray diffraction analysis (Rigaku Miniflex II) of flat crystallites shows that they grew in (001) orientation. Chemical composition analysis using a JEOL-EPMA provides a stoichiometry of $Ni_{0.959}P_{1.000}S_{2.976}$, with a relative spread $\pm 1\%$.

Bulk crystals are mechanically exfoliated onto oxidized silicon wafer pieces with adhesive tape (Ultron Systems, P/N 1007R), and adhesive residues are removed by immersion in trichloroethylene solvent⁵². To enable fast identification of exfoliated few-layer flakes by visual inspection, the thickness of the silicon oxide layer has to be chosen adequately to maximize optical interference contrast⁵³. For the measured refractive index of bulk NiPS₃ at ~550 nm, $\tilde{n} \approx 3.2 - 1.2i$, the optimum oxide thickness is 90 nm. Exfoliated samples are stored in a vacuum desiccator to minimize aging due to ambient exposure. If stored in ambient air, aging of exfoliated NiPS₃ sheets results in a reduction of the optical contrast visible in optical microscope images after about one week, accompanied by a strong reduction of peak intensities in Raman spectra; AFM measurements show that aging leads to an increase in the apparent thickness of NiPS₃ sheets by ~1 nm (see Supplementary Fig. S4). Heat treatment in ambient air results in a dramatic acceleration of sample aging. While these observations suggest that a progressive chemical degradation of exfoliated samples occurs, the detailed mechanism of this phenomenon warrants further study.

AFM characterization is performed with a Park XE-100 instrument, using dynamic force mode (cantilever spring constant ~40 N/m) in the repulsive force regime. AFM data are evaluated using the Gwyddion software package⁵⁴. Micro-Raman measurements are performed in ambient on a Renishaw inVia instrument, using a 50x microscope objective. Spectra are collected for excitation wavelengths 514.5 and 632.8 nm, using gratings containing 2400 and 1800 grooves/mm, respectively. Measurements cover the wavenumber range $100-3000~\text{cm}^{-1}$. The silicon substrate's Raman peak at $520~\text{cm}^{-1}$ is used as an internal calibration. At a laser spot size $\approx 1~\mu\text{m}$, keeping the illumination power at $\leq 1~\text{mW}$ produces no observable sample damage or changes in the acquired spectra. Each spectrum is acquired with an integration time of 10 seconds. All spectra presented in this article have been collected in a single measurement session, such that experimental conditions are identical for all spectral data. Prior to each spectral acquisition, the focus of the laser was readjusted to coincide with the plane of the NiPS₃ flake studied. All graphs showing Raman spectral intensities use identical units (1 a.u. = 1000 CCD counts). Phonon mode visualizations were drawn with VESTA⁵⁵.

References

- 1. Novoselov, K. S. et al. Electric Field Effect in Atomically Thin Carbon Films. Science 306, 666-669 (2004).
- 2. Castro Neto, A. H., Guinea, F., Peres, N. M. R., Novoselov, K. S. & Geim, A. K. The Electronic Properties of Graphene. *Rev. Mod. Phys.* 81, 109–162 (2009).
- 3. Schedin, F. et al. Detection of Individual Gas Molecules Adsorbed on Graphene. Nat. Mater. 6, 652-655 (2007).
- 4. Chen, J.-H., Jang, C., Xiao, S., Ishigami, M. & Fuhrer, M. S. Intrinsic and Extrinsic Performance Limits of Graphene Devices on SiO₂. *Nat. Nanotechnol.* **3**, 206–209 (2008).
- 5. Dean, C. R. et al. Boron Nitride Substrates for High-Quality Graphene Electronics. Nat. Nanotechnol. 5, 722–726 (2010).
- 6. Novoselov, K. S. et al. Two-Dimensional Atomic Crystals. Proc. Natl. Acad. Sci. USA 102, 10451–10453 (2005).
- 7. Sandilands, L. J. et al. Stability of Exfoliated $Bi_2Sr_2Dy_xCa_{1-x}Cu_2O_{8+\delta}$ Studied by Raman Microscopy. Phys. Rev. B 82, 064503 (2010).
- 8. Ayari, A., Cobas, E., Ogundadegbe, O. & Fuhrer, M. S. Realization and Electrical Characterization of Ultrathin Crystals of Layered Transition-Metal Dichalcogenides. *J. Appl. Phys.* **101**, 014507 (2007).
- 9. Mak, K. F., Lee, C., Hone, J., Shan, J. & Heinz, T. F. Atomically Thin MoS₂: A New Direct-Gap Semiconductor. *Phys. Rev. Lett.* **105**, 136805 (2010).
- 10. Splendiani, A. et al. Emerging Photoluminescence in Monolayer MoS₂. Nano Lett. 10, 1271-1275 (2010).
- 11. Geim, A. & Grigorieva, I. Van der Waals Heterostructures. Nature 499, 419-425 (2013).
- 12. Wolf, S. et al. Spintronics: A Spin-Based Electronics Vision for the Future. Science 294, 1488–1495 (2001).
- 13. Klingen, W., Ott, R. & Hahn, H. Über die Darstellung und Eigenschaften von Hexathio- und Hexaselenohypodiphosphaten. Z. Anorg. Allg. Chem. 396, 271–278 (1973).
- 14. Klingen, W., Eulenberger, G. & Hahn, H. Über die Kristallstrukturen von Fe₂P₂Se₆ und Fe₂P₂Se₆. Z. Anorg. Allg. Chem. **401**, 97–112 (1973).
- Brec, R. Review on Structural and Chemical Properties of Transition Metal Phosphorous Trisulfides MPS₃. Solid State Ionics 22, 3–30 (1986).
- 16. Ouvrard, G., Brec, R. & Rouxel, J. Structural Determination of Some MPS₃ Layered Phases (M = Mn, Fe, Co, Ni and Cd). *Mater. Res. Bull.* 20, 1181–1189 (1985).
- 17. Le Flem, G., Brec, R., Ouvard, G., Louisy, A. & Segransan, P. Magnetic Interactions in the Layer Compounds MPX₃ (M = Mn, Fe, Ni; X = S, Se). *J. Phys. Chem. Solids* 43, 455–461 (1982).
- 18. Kurosawa, K., Saito, S. & Yamaguchi, Y. Neutron Diffraction Study on MnPS3 and FePS3. J. Phys. Soc. Japan 52, 3919-3926 (1983).
- Li, X., Cao, T., Niu, Q., Shi, J. & Feng, J. Coupling the Valley Degree of Freedom to Antiferromagnetic Order. Proc. Natl. Acad. Sci. USA 110, 3738–3742 (2013).
- Li, X., Wu, X. & Yang, J. Half-Metallicity in MnPSe₃ Exfoliated Nanosheet with Carrier Doping. J. Am. Chem. Soc. 136, 11065–11069 (2014).
- 21. Brec, R., Schleich, D. M., Ouvrard, G., Louisy, A. & Rouxel, J. Physical Properties of Lithium Intercalation Compounds of the Layered Transition Chalcogenophosphates. *Inorg. Chem.* 18, 1814–1818 (1979).
- 22. Foot, P. J. S. *et al.* The Structures and Conduction Mechanisms of Lithium-Intercalated and Lithium-Substituted Nickel Phosphorus Trisulphide (NiPS₃), and the Use of the Material as a Secondary Battery Electrode. *Phys. Status Solidi A* **100**, 11–29 (1987).
- 23. Yang, D., Westreich, P. & Frindt, R. F. Exfoliated CdPS₃ Single Layers and Restacked Films. J. Solid State Chem. 166, 421-425 (2002).
- 24. Frindt, R. F., Yang, D. & Westreich, P. Exfoliated Single Molecular Layers of Mn_{0.8}PS₃ and Cd_{0.8}PS₃. J. Mater. Res. 20, 1107–1112 (2005).
- Li, H. et al. Rapid and Reliable Thickness Identification of Two-Dimensional Nanosheets Using Optical Microscopy. ACS Nano 7, 10344–10353 (2013).

- 26. Gupta, A., Chen, G., Joshi, P., Tadigadapa, S. & Eklund, P. C. Raman Scattering from High-Frequency Phonons in Supported n-Graphene Layer Films. Nano Lett. 6, 2667-2673 (2006)
- 27. Li, S.-L. et al. Quantitative Raman Spectrum and Reliable Thickness Identification for Atomic Layers on Insulating Substrates. ACS Nano 6, 7381-7388 (2012).
- 28. Chakraborty, B., Matte, H. S. S. R., Sood, A. K. & Rao, C. N. R. Layer-Dependent Resonant Raman Scattering of a Few Layer MoS, J. Raman Spectrosc. 44, 92-96 (2013).
- 29. Li, H. et al. From Bulk to Monolayer MoS2: Evolution of Raman Scattering. Adv. Funct. Mater. 22, 1385-1390 (2012).
- 30. Yamamoto, M. et al. Strong Enhancement of Raman Scattering from a Bulk-Inactive Vibrational Mode in Few-Layer MoTe₂. ACS Nano 8, 3895-3903 (2014).
- 31. Hajiyev, P., Cong, C., Qiu, C. & Yu, T. Contrast and Raman Spectroscopy Study of Single- and Few-Layered Charge Density Wave Material: 2H-TaSe2. Sci. Rep. 3, 2593 (2013).
- 32. Ishigami, M., Chen, J., Cullen, W., Fuhrer, M. & Williams, E. Atomic Structure of Graphene on SiO₂. Nano Lett. 7, 1643–1648 (2007).
- 33. Tuinstra, F. & Koenig, J. L. Raman Spectrum of Graphite. J. Chem. Phys. 53, 1126-1130 (1970).
- 34. Ferrari, A. C. et al. Raman Spectrum of Graphene and Graphene Layers. Phys. Rev. Lett. 97, 187401 (2006).
- 35. Ferrari, A. C. & Basko, D. M. Raman Spectroscopy as a Versatile Tool for Studying the Properties of Graphene. Nat. Nanotechnol. 8, 235-246 (2013).
- 36. Lee, C. et al. Anomalous Lattice Vibrations of Single- and Few-Layer MoS₂. ACS Nano 4, 2695–2700 (2010).
- 37. Berkdemir, A. et al. Identification of Individual and Few Layers of WS2 Using Raman Spectroscopy. Sci. Rep. 3, 1755 (2013).
- 38. Zeng, H. et al. Optical Signature of Symmetry Variations and Spin-Valley Coupling in Atomically Thin Tungsten Dichalcogenides. Sci. Rep. 3, 1608 (2013).
- 39. Mathey, Y., Clement, R., Sourisseau, C. & Lucazeau, G. Vibrational Study of Layered MPX₃ Compounds and of Some Intercalates with $\text{Co}(\eta^5 - C_5 \text{H}_5)_2^+$ or $\text{Cr}(\eta^6 - C_6 \text{H}_6)_2^+$. Inorg. Chem. 19, 2773–2779 (1980).
- 40. Sourisseau, C., Forgerit, J. P. & Mathey, Y. Vibrational Study of the $[P_2S_6^4]$ Anion, of Some MPS₃ Layered Compounds (M = Fe, Co, Ni, In_{2/3}), and of Their Intercalates with $[Co(\eta^5 - C_5H_5)_3^+]$ Cations. *J. Solid State Chem.* **49**, 134–149 (1983). 41. Scagliotti, M., Jouanne, M., Balkanski, M. & Ouvrard, G. Spin Dependent Phonon Raman Scattering in Antiferromagnetic FePS₃
- Layer-Type Compound. Solid State Commun. 54, 291-294 (1985).
- 42. Scagliotti, M., Jouanne, M., Balkanski, M., Ouvrard, G. & Benedek, G. Raman Scattering in Antiferromagnetic FePS₃ and FePSe₃ Crystals. Phys. Rev. B 35, 7097-7104 (1987).
- 43. Balkanski, M., Jouanne, M. & Scagliotti, M. Magnetic Ordering Induced Raman Scattering in FePS3 and NiPS3 Layered Compounds. Pure Appl. Chem. 59, 1247-1252 (1987)
- 44. Bernasconi, M. et al. Lattice Dynamics of Layered MPX₃ (M = Mn, Fe, Ni, Zn; X = S, Se) Compounds. Phys. Rev. B 38, 12089–12099 (1988)
- 45. Rosenblum, S. S. & Merlin, R. Resonant Two-Magnon Raman Scattering at High Pressures in the Layered Antiferromagnetic NiPS₃. Phys. Rev. B 59, 6317-6320 (1999).
- 46. Wang, Y. Y., Ni, Z. H., Shen, Z. X., Wang, H. M. & Wu, Y. H. Interference Enhancement of Raman Signal of Graphene. Appl. Phys. Lett. 92, 043121 (2008).
- 47. Lee, J.-U., Park, J., Son, Y.-W. & Cheong, H. Anomalous Excitonic Resonance Raman Effects in Few-Layered MoS₂. Nanoscale 7, 3229-3236 (2015).
- 48. Terrones, H. et al. New First Order Raman-Active Modes in Few Layered Transition Metal Dichalcogenides. Sci. Rep. 4, 4215 (2014).
- 49. Scholl, A. et al. Observation of Antiferromagnetic Domains in Epitaxial Thin Films. Science 287, 1014-1016 (2000).
- 50. Scholl, A., Ohldag, H., Nolting, F., Stöhr, J. & Padmore, H. X-ray Photoemission Electron Microscopy, a Tool for the Investigation of Complex Magnetic Structures. Rev. Sci. Instr. 73, 1362-1366 (2002).
- 51. Taylor, B. E., Steger, J. & Wold, A. Preparation and Properties of Some Transition Metal Phosphorus Trisulfide Compounds. J. Solid State Chem. 7, 461-467 (1973).
- 52. Banda, E. J. K. B. Optical Absorption of NiPS3 in the Near-Infrared, Visible and Near-Ultraviolet Regions. J. Phys. C Solid State 19, 7329-7335 (1986)
- 53. Ni, Z. H. et al. Graphene Thickness Determination Using Reflection and Contrast Spectroscopy. Nano Lett. 7, 2758-2763 (2007).
- 54. Nečas, D. & Klapetek, P. Gwyddion: an Open-Source Software for SPM Data Analysis. Cent. Eur. J. Phys. 10, 181-188 (2012).
- 55. Momma, K. & Izumi, F. VESTA 3 for Three-Dimensional Visualization of Crystal, Volumetric and Morphology Data. J. Appl. Crystallogr. 44, 1272 (2011).
- 56. Temple, P. & Hathaway, C. Multiphonon Raman Spectrum of Silicon. Phys. Rev. B 7, 3685-3697 (1973).

Acknowledgements

This work was supported by IBS-R009-D1 and IBS-R009-G1. M.H. acknowledges sabbatical year research support by University of Seoul (2014).

Author Contributions

J.G.P. conceived and supervised the project. K.B. grew the NiPS₃ crystals and performed bulk characterizations. C.T.K. and M.N. prepared exfoliated samples and characterized them by AFM and brightfield microscopy. M.N. performed the Raman measurements and analyzed the spectra. H.J.P. collected ellipsometry data. The work of C.T.K., M.N. and H.J.P. was carried out with guidance from M.H. and T.W.N. S.K. performed magnetic susceptibility measurements. H.W.S. performed optical interference calculations. J.H.K. and B.H.H. assisted with optical measurements. M.N. wrote the paper with help from C.T.K. under the guidance of J.G.P. All co-authors contributed to the discussion of the data.

Additional Information

Supplementary information accompanies this paper at http://www.nature.com/srep

Competing financial interests: The authors declare no competing financial interests.

How to cite this article: Kuo, C.-T. et al. Exfoliation and Raman Spectroscopic Fingerprint of Few-Layer NiPS₃ Van der Waals Crystals. Sci. Rep. 6, 20904; doi: 10.1038/srep20904 (2016).

This work is licensed under a Creative Commons Attribution 4.0 International License. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in the credit line; if the material is not included under the Creative Commons license, users will need to obtain permission from the license holder to reproduce the material. To view a copy of this license, visit http://creativecommons.org/licenses/by/4.0/